

计算光学成像与 光信息处理技术前沿

(第7讲)

左超

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What is computational imaging?





The principle of STED-microscopy









H. Hughes Medical Institute USA

Germany

Stanford University USA

The Royal Stardiik Academy of Sciences has decided to award the 2014 NOBEL PRIZE IN CHEMISTRY

https://www.nobelprize.org/prizes/chemistry/2014/press-release/

超分辨荧光显微镜 - 分辨率可以超越衍射极限



一个荧光蛋白分子激发形成的艾里斑尺寸约200nm

https://www.nobelprize.org/prizes/chemistry/2014/press-release/

<u>超分辨荧光显微镜</u> – 分辨率可以超越衍射极限



Lothar Schermelleh, Rainer Heintzmann, Heinrich Leonhardt, The Journal of Cell Biology Jul 2010, 190 (2) 165-175;

超分辨荧光显微镜SIM – 分辨率可以超越衍射极限



Why computational imaging? 超分辨荧光显微镜STED – 分辨率可以超越衍射极限

b a C Detector 淬灭面包圈区域以减小等效psf Phase tra S1 mask STED Saturated Excitation Effective PSF STED laser pattern depletion Excitation Excitation laser Zero point Objective S_o Confocal STED Sample raw Fluorescence Excitation STED-microscopy 6 Stimulated Emission 3 80 nm Exciting laser Quenching laser beam 2 beam 20

lish Academy of Sciences

Stefan W. Hell, Science Vol. 316, Issue 5828, pp. 1153-1158

Why computational imaging? 超分辨荧光显微PALM/STORM-超越衍射极限



Michael J Rust, Mark Bates & Xiaowei Zhuang, Nature Methods volume 3, pages 793-796 (2006)

Why computational imaging? 超分辨荧光显微镜 – 分辨率超越衍射极限



Eric Betzig (born 1960) H. Hughes Medical Institute USA

ERIC BETZIG

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Stefan W. Hell (born 1962) Max Planck Institute Germany

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German citizen. Born 1962 in Arad, Romania. Ph.D. 1990 from the University of Heidelberg, Germany. Director at the Max Planck Institute for Biophysical Chemistry, Göttingen, and Division head at the German Cancer Research Center, Heidelberg, Germany.

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USA

William E. Moerner

(born 1953)

Stanford University

WILLIAM E. MOERNER

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http://web.stanford.edu/group/moerner





https://www.nobelprize.org/prizes/chemistry/2014/press-release/



C Zuo, J Sun, J Li, J Zhang, A Asundi, Q Chen Scientific Reports 7, 7654, (2017).





https://en.wikipedia.org/wiki/Light-field_camera



Beck S M, Buck J R, Buell W F, et al.. Applied Optics, 2005, 44(35): 7621–7629.





https://en.wikipedia.org/wiki/Coded_aperture



C Zuo, J Sun, J Li, J Zhang, A Asundi, Q Chen Scientific Reports 7, 7654, (2017).

Computational microscopy

与显微成像相关的诺贝尔奖	1925	Richard Zsigmondy	超显微镜(暗场)
	1953	Frits Zernike	相衬显微镜
	1971	Dennis Gabor	全息摄影
	1974	Martin Ryle	射电望远镜/合成孔径
	1981	Kai Siegbahn	电子光谱仪
	1981	Nicolaas Bloembergen Arthur Schawlow	激光光谱仪
	1986	Ernst Ruska	电子显微镜
	1986	Gerd Binning Heinrich Rohrer	扫描隧道显微镜
	2008	Osamu Shimomura Martin Chalfie Roger Y. Tsien	绿色荧光蛋白
	2009	Willaed S. Boylean George Smith	电荷耦合器件(CCD)
	2014	Eric Betzig Stefan W. Hell William E. Moerner	超分辨率荧光显微成像
	2017	Jacques Dubochet Joachim Frank Richard Henderson	冷冻电镜
	2018	Arthur Ashkin	光学镊子





Dark field (Ultra) microscope R. Zsigmondy, 1903



Phase contrast microscope F. Zernike, 1932



Fluorescence microscopy O. Shimomura, M. Chalfie and R. Tsien early 20th century



Superresolution fluorescence microscopy E. Betzig, S.W. Hell and W. E. Moerner late 20th century



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Phase contrast microscope F. Zernike, 1932



Superresolution fluorescence microscopy E. Betzig, S.W. Hell and W. E. Moerner late 20th century



Nobel Prize for Chemistry, 1925 R. Zsigmondy



Nobel Prize for Chemistry, 2008 O. Shimomura, M. Chalfie and R. Tsien



Nobel Prize for Physics, 1953 F. Zernike



Nobel Prize for Chemistry, 2014 E. Betzig, S.W. Hell and W. E. Moerner

主要瓶颈问题:无标记非干涉相位显微成像



传统透镜式成像 点对点光强信号探测

2014年12月 2014 NOBEL PRIZE IN CHEMISTRY 微观局限: PERSPECTIVE Nature Method Live-cell mass profiling: an emerging 无法定量探测相位 approach in quantitative biophysics Thomas A Zangle1 & Michael A Teitell1-6 未染色细胞 大部分生物细胞无色透明, 荧光标记 is selling a system based on ptychography for quantitative phase imaging of biological samples⁶². There are several DHM systems available through Phase Holographic Imaging (Sweden), Lyncée 成像依赖染色标记 Tec (Switzerland), 4Deep Inwater Imaging (Canada) and Ovizio 侵入 <mark>-</mark>成像 Imaging Systems (Belgium). Future technological developments will likely focus on resolution improvement, integration with other imaging modalities and the use of quantitative phase information in new ways, as has been (Inv -free) done in the past with extensions to the measurement of intracellular transport^{49,70}. The development of quantitative phase imaging in living tissue would be a remarkable advance, as it would allow for cell growth quantification ole organisms, Single-cell mass "定量相位成像技术" © 2014 将是未来实现下一代无标记 (H 细胞成像的一项重大进展 (remarkable advance) Amplitude ansmit NATURE METHODS | VOL.11 NO.12 | DECEMBER 2014 | 1221

Computational microscopy



Phase measurement

Interference based method • Interferometry Digital holography •



Shack-Hartmann wave-front sensor





- Phase retrieval•Iterative: Gerchberg–Saxton etc.^{1,2}•Direct: Transport-of-intensity equation³

[1] J. R. Fienup, Appl. Opt. 21, 2758-2769 (1982).

[2] R.W. Gerchberg and W. O. Saxton, Optik 35, 237–246(1972)

[3] M. Reed Teague, J. Opt. Soc. Am. 73, 1434-1441 (1983).



数字全息显微 Digital Holographic Microscopy (DHM)



数字全息显微 Digital Holographic Microscopy (DHM)







Hologram







3D Profile



Line Profile

C. Zuo, Q. Chen, W. Qu and A. Asundi, Chapter 3: Digital Holography for Three-Dimensional Metrology: Principles, Methods, and Applications, in Ella Myers (ed.) Advances in Digital Holography Research. ISBN: 9781608764747.

数字全息显微 Digital Holographic Microscopy (DHM)





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FSM-Precision



飞时曼数字全息显微镜 (我国首台商业化数字全息显微镜)









Digital Camera



飞时曼数字全息显微镜(我国首台商业化数字全息显微镜)





















飞时曼数字全息显微镜(我国首台商业化数字全息显微镜)

无透镜全息显微 Lensless Holographic Microscopy



C. Zuo, Q. Chen, W. Qu and A. Asundi, Chapter 3: Digital Holography for Three-Dimensional Metrology: Principles, Methods, and Applications, in Ella Myers (ed.) Advances in Digital Holography Research. ISBN: 9781608764747.

无透镜全息显微 Lensless Holographic Microscopy



C. Zuo, Q. Chen, W. Qu and A. Asundi, Chapter 3: Digital Holography for Three-Dimensional Metrology: Principles, Methods, and Applications, in Ella Myers (ed.) Advances in Digital Holography Research. ISBN: 9781608764747.

无透镜全息显微 Lensless Holographic Microscopy



3D Profiling and Measurements



MEMS and Nano-metrology



C. Zuo, Q. Chen, W. Qu and A. Asundi, Chapter 3: Digital Holography for Three-Dimensional Metrology: Principles, Methods, and

Applications, in Ella Myers (ed.) Advances in Digital Holography Research. ISBN: 9781608764747.

A. Asundi, Digital Holography for MEMS and Microsystem Metrology, Wiley-vch Verlag, Ed. Weinheim, 2011

Phase aberration compensation



The quadratic aberration induced by MO broadened the spectrum

Both tilt and defocus are fail to compensated by spectrum centering

Macrophage cells without phase compensation

Phase aberration compensation







First dominant PC



Refine by 1D fitting

Macrophage cells with PCA compensation





Compensated hologram

C. Zuo, Q. Chen, W. Qu, A. Asundi, Optics Letters **38**, 1724-1726 (2013). J. Sun, Q. Chen, Y. Zhang, and C. Zuo, Optics Letters **41**,1293-1296 (2016).

Phase aberration compensation



Macrophage cells with PCA phase compensation





C. Zuo, Q. Chen, W. Qu, A. Asundi, Optics Letters **38**, 1724-1726 (2013). J. Sun, Q. Chen, Y. Zhang, and C. Zuo, Optics Letters **41**,1293-1296 (2016).



Thank you